

<b>PTO/SB/08A</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)		<b>Complete if Known</b>		
		Application Number	10/039,459	
		Filing Date	November 7, 2001	
		Confirmation Number		
		First Named Inventor	Sreedharamurthy	
		Group Art Unit		
		Examiner Name		
Sheet	1	2	Attorney Docket No.	MEMC 99-1250 (2441.1)



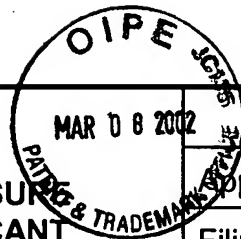
U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY		
		Number	Kind Code <sup>2</sup> (if known)				
MS	1	5,922,127		Luter et al.	07/13/1999		
MS	2	5,942,032		Kim et al.	08/24/1999		
FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>
		Office	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)			
OTHER ART - NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.					T <sup>6</sup>
MS	3	DAMIEN GILMORE, et al., "The Impact of Furnace Graphite Parts on CZ-Grown Single Crystal Silicon's Radial Impurity Distribution", Electrochemical Society Proceedings, pages 102-113, Volume 96-13					

Examiner Signature	<i>Mark Sg</i>	Date Considered	11/15/02
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

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PTO/SB/08A				<b>Compleat if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				Application Number	10/039,459
				Filing Date	November 7, 2001
				Confirmation Number	
				First Named Inventor	Sreedharamurthy
				Group Art Unit	
				Examiner Name	
Sheet	2	of	2	Attorney Docket No.	MEMC 99-1250 (2441.1)

MS	4	DAMIEN GILMORE, et al., "The Impact of Graphite Furnace Parts on Radial Impurity Distribution in Czochralski-Grown Single-Crystal Silicon", Journal of the Electrochemical Society, February 1998, pages 621-628, Volume 145, No. 2	

Examiner Signature	<i>Matt Eg</i>	Date Considered	11/19/2002
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PTO/SB/08A <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/039,459
				Filing Date	11/07/2001
				Confirmation Number	1061
				First Named Inventor	H. Sreedharamurthy
				Group Art Unit	1765
				Examiner Name	
Sheet	1	of	1	Attorney Docket No.	MEMC 99-1250/2441.1

## U.S. PATENT DOCUMENTS

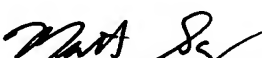
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code <sup>2</sup> (if known)		
MS	5	4,194,028		Sirtl et al.	03-18-1980

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sup>6</sup>
		Office	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)			
MS	6	WO	99/66108	A1	MEMC Electronic Materials, Inc.	12-23-1999	
MJ	7	JP	07 257987 Abstract Only		Sumitomo Sitix Corp.	10-09-1995	

## OTHER ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
MS	8	A. L. P. ROTONDARO et al. "Impact of Fe and Cu Contamination on the Minority Carrier Lifetime of Silicon Substrates" J. Electrochem. Soc., Vol. 143, No. 9 (9/1996). pp. 3014-3019.	
MJ	9	PCT International Search Report issued for PCT/US01/50968 dated August 7, 2002.	

Examiner Signature		Date Considered	11/14/02
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